

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: OHMI, et al

Serial No.: 10/566,241

Filed: January 30, 2006

Title: Microwave Plasma Processing Method, Microwave
Plasma Processing Apparatus, and It's Plasma Head

Art Unit:

**INFORMATION DISCLOSURE STATEMENT**
UNDER 37 CFR 1.97 & 1.98Mail Stop: DD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

May 30, 2006

Sir:

In the matter of the above-identified application, applicant(s) are submitting herewith copies of the documents listed in the attached Form(s) PTO/SB/08A and/or PTO/SB/08B for the Examiner's consideration.

This information disclosure statement is being submitted before the mailing date of a first office action.

To the extent that the documents listed on the attached form equivalent to Form(s) PTO/SB/08A and/or PTO/SB/08B are not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by an English language translation of the documents and the disclosure in the specification.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

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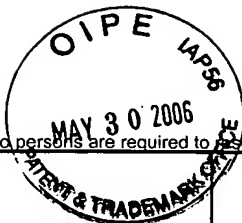
Respectfully submitted,

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Complete if Known

Application Number	10/566,241
Filing Date	January 30, 2006
First Named Inventor	Tadahiro OHMI
Group Art Unit	
Examiner Name	
Attorney Docket Number	45832X00

Sheet

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of

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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		Nikkei Microdevices 2001-1, To The Breakthrough Of Plasma CVD Technological LSI Production Revolution Which Does Not Use The Vacuum, page 3	
		Nikkei Microdevices 2001-4, Plasma Technology Which Does Not Use Vacuum, pp 139-146	

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing the this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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